Am ndm nts to th Sp cification

At page 1 before the "Technical Field" section, please insert the following:

--RELATED PATENT DATA

This patent resulted from a divisional application of U.S. Patent Application Serial No. 10/071,425, filed February 8, 2002, entitled "Semiconductor Processing Method Using Photoresist and an Antireflective Coating", naming Terry L. Giltón, Steve W. Bowes, John T. Moore, Joseph F. Brooks and Kristy A. Campbell as inventors, the disclosure of which is incorporated by reference.--